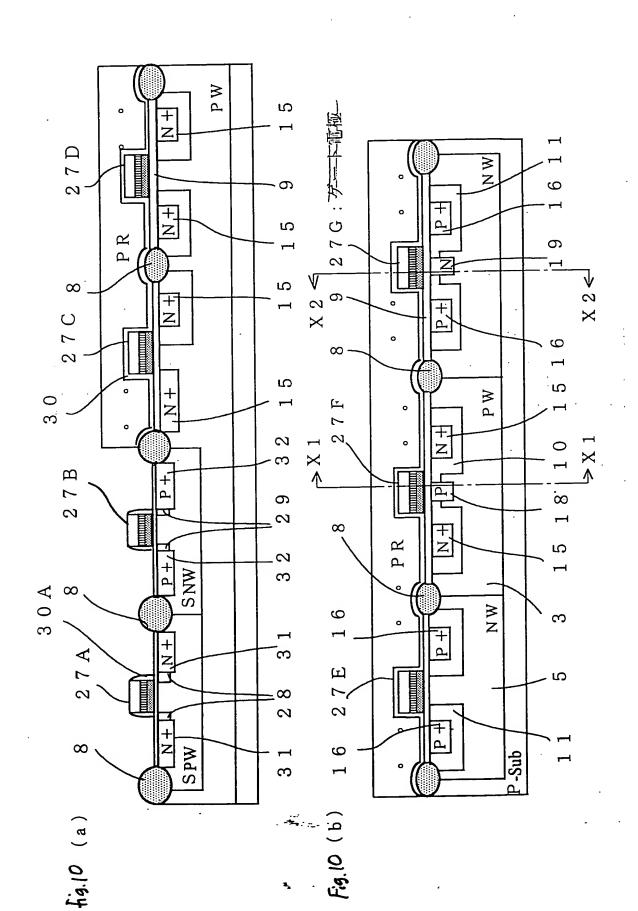


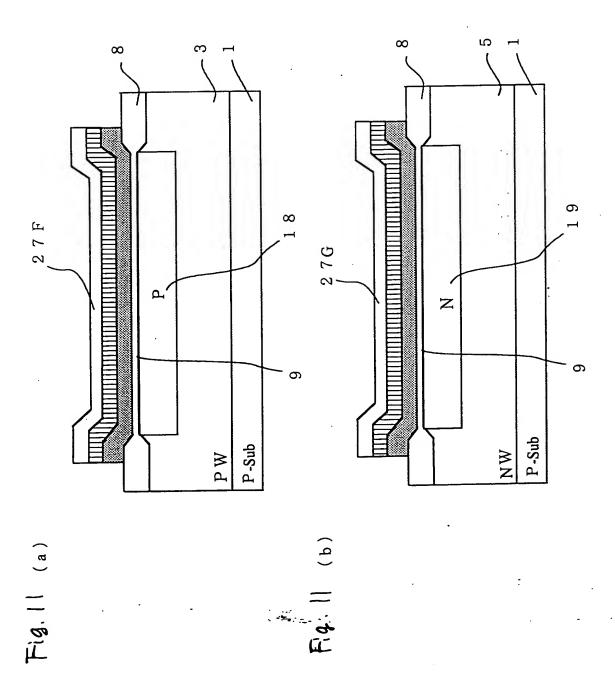
Matter No.: 10417-039002

Applicant(s): Toshimitsu Taniguchi et al. SEMICONDUCTOR DEVICE AND METHOD OF

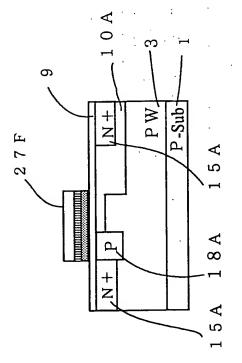
MANUFACTURING THEREOF



Page 11 of 14



Page 12 of 14



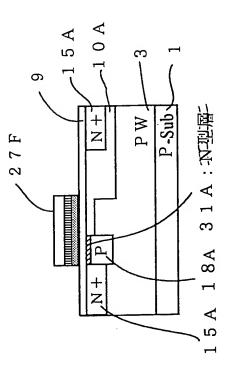


Fig. 12 (a)

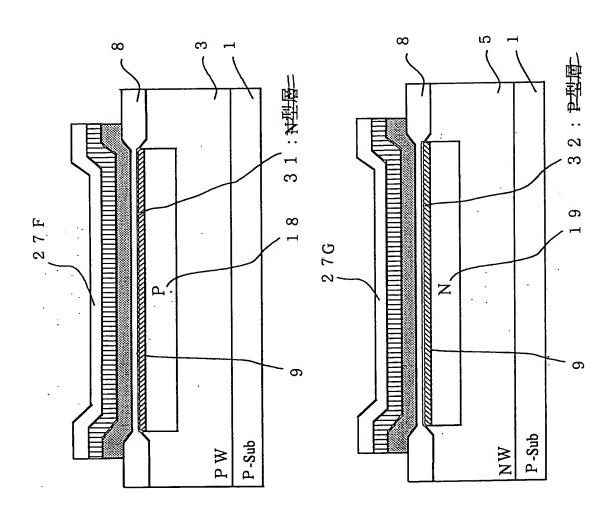


Fig. 13 (a)

Page 14 of 14

